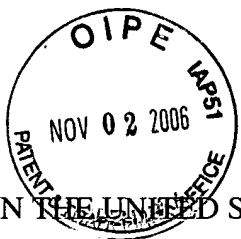


10/699,763



PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Dirk Basting et al.

Application No.: 10/699,763

Filed: November 3, 2003

For: EXCIMER OR MOLECULAR
FLUORINE LASER SYSTEM WITH
PRECISION TIMING

Confirmation No.: 4237

Group Art Unit: 2828

Examiner: Rory B. Finneren

**RESPONSE TO ADVISORY ACTION
MAILED SEPTEMBER 27, 2006**

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M/S RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents, P.O.
Box 1450, Alexandria, VA 22313-1450 on October 27, 2006.
STALLMAN & POLLOCK LLP

Dated: 10/27/2006

By: Georgia K. Stith

Georgia K. Stith

Sir:

In response to the Advisory Action dated September 27, 2006, and in conjunction with the filing of a Request for Continued Examination (RCE) and a three-month extension of time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

11/03/2006 AWONDAF1 00000120 10699763

02 FC:1253

1020.00 0P

Atty Docket No.: LMPY-20310 [358/U]